# Overview of DMCS Projects and MicroTCA.4 Developments

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MicroTCA\_4 for Industry and Research



kowski on behalf of DMCS Tean Imber 5, 2018



#### Agenda

- Introduction
- High-Power Piezo Driver for Accelerator Applications
- Management Controller Developments for xTCA Systems
- Image Acquisition and Processing System in MicroTCA.4
- Conclusions







## High-Power Piezo Driver for Accelerator Applications



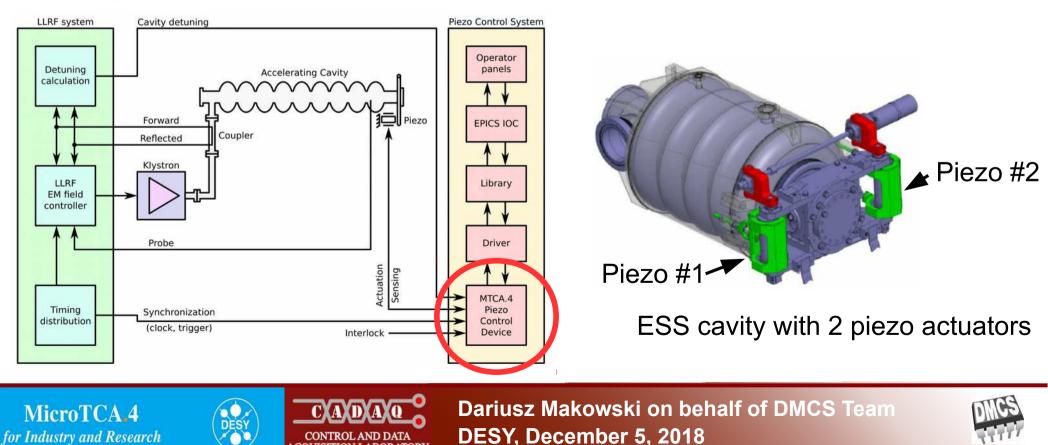




### **High Power Piezo Driver - Motivation**

COLUSITION LABORATO

- This work is being done in frame of the Polish in-kind delivered by the Polish Electronic Group (PEG) within in-kind agreement signed between PEG and ESS on 2016-11-08, (together with Schedule AIK 8.2, signed 09.2017, ESS-0060409)
- Department of Microelectronics and Computer Science, Lodz University of Technology as a member of PEG consortium is responsible for piezo driver system delivery for elliptical cavities of ESS linac.



#### **Piezo Actuators Planned for ESS Accelerator**

Cavity type	Piezo actuator type		
Medium Beta cavities	Noliac NAC 2022 H30		
High Beta cavities	Noliac NAC 2022 H30		
Spoke cavities	Piezo #1: Noliac NAC2022-H90-A01 Piezo #2: PI PICMA P-888.91/51		

Piezo type	Noliac NAC 2022 H30	Noliac NAC 2022 H90	PI Stack 2x P-888.90 + 1x P-888.50
Dimensions	10 x 10 x 30 mm	10 x 10 x 90 mm	10 x 10 x 90 mm
Cell material	NCE51F	NCE51F	PIC252
Number of cells	15	45	
Total capacitance (room temp.)	5.54 µF ±15%	17.4 μF ±15%	32 μF ±20%
Total capacitance (cryo, 20 K)	~1.85 μF	~5.8 µF	~9.8 µF
Max. free stroke	46.2 μm	145.2 μm	94 µm
Blocking force	4200 N	4200 N	3600 N
Max. operating voltage	200 V (±100 V)	200 V (±100 V)	-20 to 120 V
Max. operating temperature	200°C	200°C	150°C

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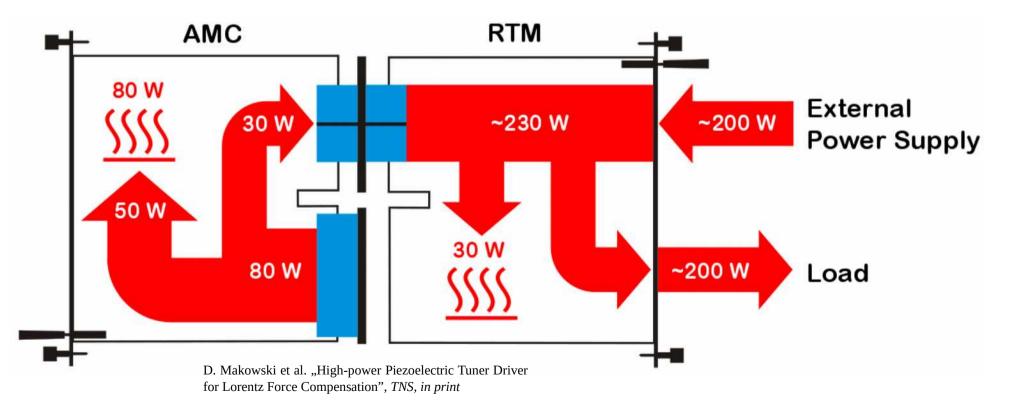




#### **Challenges of Piezo Driver Implementation in MicroTCA.4 Form Factor**

#### Decided to use solution III AMC + RTM card + External PSM

- 1. 5-10 Watts for Payload (from AMC)
- 2. Untimed power for Piezo Driver from external power supply
- 3. Limited piezo power by cooling capability to ~20-25 Watts









#### **Piezo Driver RTM Module – Second Prototype**

- Based on high efficiency Class-D amplifier (PWM)
- 2 channels available:
  - 2x 35 Watts (MTCA.4 power supply)
  - 2x 100 Watts (external power supply)
- Piezo driver and piezo sensor mode
- Build-in diagnostics (advanced implementation of RMC)
- Various protection mechanisms for both Piezo channels to protect driver itself and piezo actuator



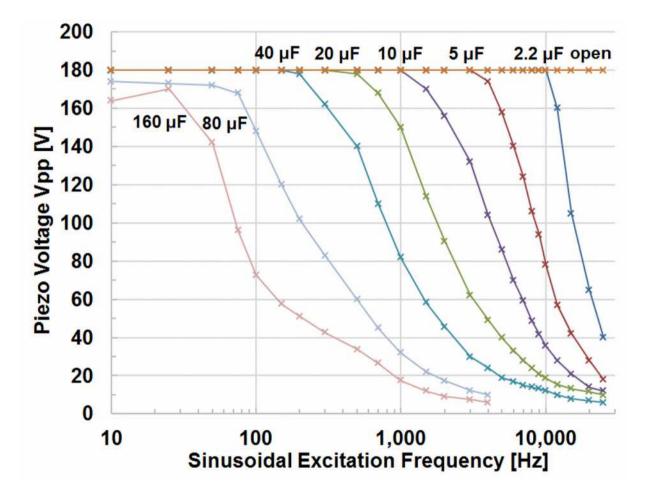






#### **Piezo Control Device – SOA Characteristics**

- Tested at laboratory conditions
- Single channel
  - Channel A as driver
  - Channel B as sensor
- 2.2 μF to 160 μF load
- Sinusoidal test signal
  - 10 pulses
  - 14 Hz repetition rate
- Various protections limit the maximum frequency of operation

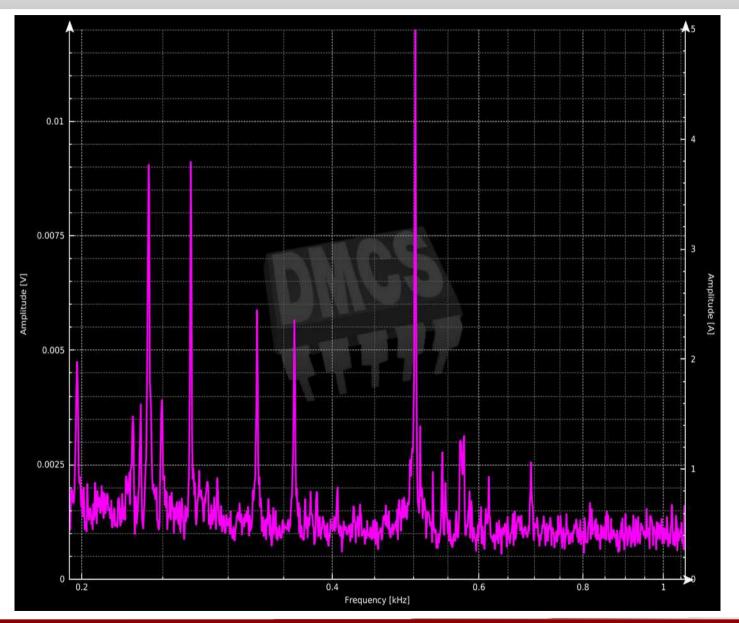








#### Cavity Resonances [200 Hz – 1 kHz]

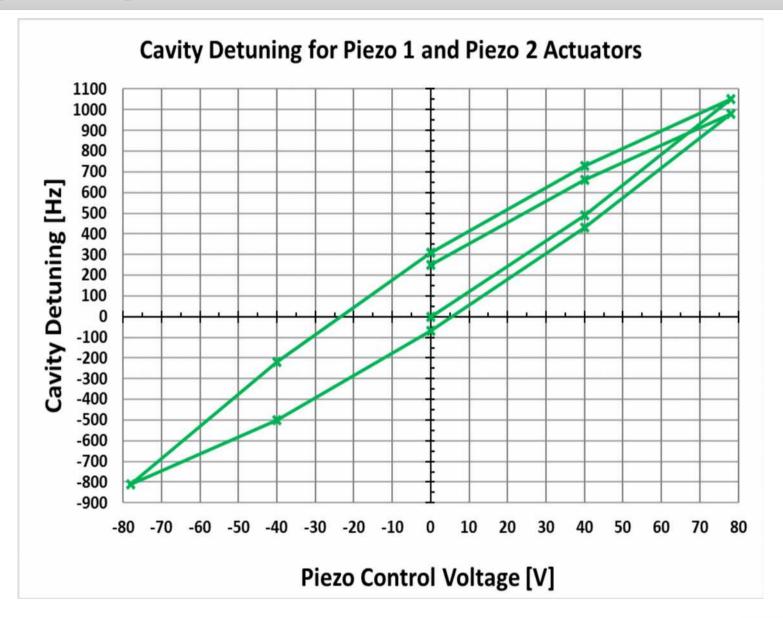








#### **Cavity Detuning for Piezo 1 and Piezo 2 actuators**









#### **Interested – Visit our Poster**

- Designed a two channel 2x 100 Watts PWM piezo driver prototype (HPD-200)
- Two solutions available:

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- Internal MicroTCA.4 and,
- External power supply
- Suitable for driving large piezo actuators (room temperature capacitance <160 µF)</li>
- Prototype successfully tested in laboratory and cryo-conditions
- Initial compensation of LFD for elliptical cavity of ESS accelerator
- Starting pre-production and mass production next year



#### Lodz University of Technology Department of Microelectronics and Computer Science



A Typical Piezo Compensation System

#### High-Power Piezo Driver for Accelerator Applications

Dariusz Makowski, Aleksander Mielczarek, Piotr Perek, Grzegorz Jablonski, Aleksander Szubert, Pawel Plewinski, Wojciech Cichalewski, Andrzej Napieralski

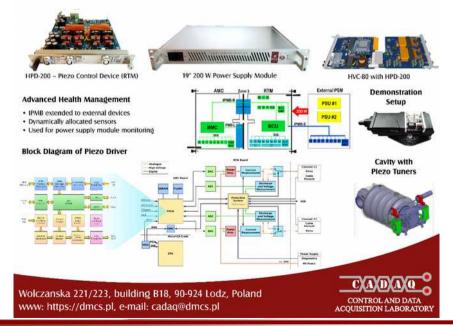
#### Accelerating Cavity Detuning Compensation

- The cavity detuning can be easily calculated by an LLRF system
- Detuning compensation reduces power loss and helps maintaining the flat-top
- Main causes for the detuning are the Lorentz force and microphonics
- Compensation requires application of mechanical impulse to the cavity

#### The actuation is done with piezoelectric elements

#### Piezo Compensation System Developed by DMCS

- System implemented almost completely in the MicroTCA.4 architecture
   Two channels, configurable in actuator or sensor mode
- Two channels, configurable in actuator or sen
   Safe discharge of the piezo-element
- Sale discharge of the piezo-element
   Up to 100 W per output channel, simultaneous operation possible
- Live monitoring of power delivered to the actuator
- Extensive health monitoring through IPMI







## Management Controller Developments for xTCA Systems







#### Intelligent Platform Management Controller for AdvancedTCA

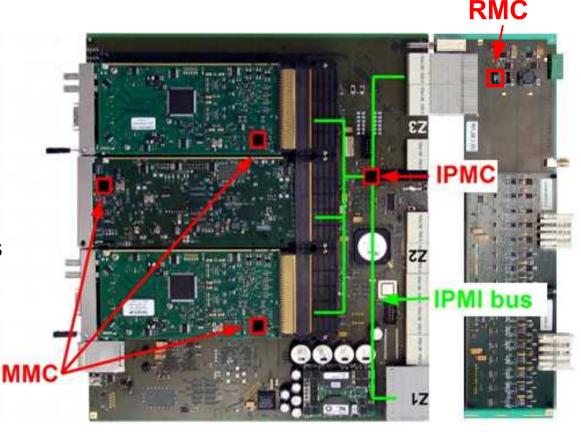
- AdvancedTCA board requires:
  - IPMC IPMI controller implemented on ATCA carrier
  - MMC controller needed on each AMC card
  - RTC controller on RTM card
- Various microcontrollers tests:
  - Atmel, NXP, Renesas
- IPMC final solution available with Renesas that offer 6 I2C controllers
  - Complex solution that requires a lot of work
- MMC mainly based on Atmel ATxmega
  - Much simpler than IPMC
- Time consuming and challenging task, but we learned a lot during this exercise

ATCA carrier with 3 AMC slots and RTM (before MTCA.4, <2007)









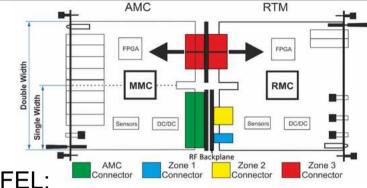
### **Development of MMC 1.0 solution for DESY**

### Unified solution for AMC and RTM cards

- Basic and Advanced versions available
- Includes hardware (schematics) and firmware
  - Microcontroller and CPLD
- Implemented on various AMC-RTM modules of E-XFEL:
  - TCK7, DAMC2, SIS8325, DS-800,...
  - VM2LF, DWC10, CLKFT, uLOG,...
- Available evaluation kits
- Based on previous work (AdvancedTCA)

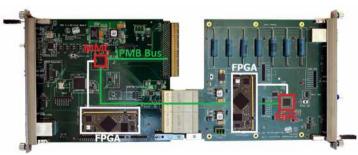
## Many new ideas implemented

- New RTM solution part of MicroTCA.4.1
- Monitoring and diagnostics
- RTM currents and voltages monitoring
- Support of PMBus DC/DC converters
- Payload management and monitoring





TCK7 and VM2 Devices



#### AMC and RTM Evaluation kits







Zone 3

AMC

### **Extension of IPMI Management for MicrtoTCA.4**

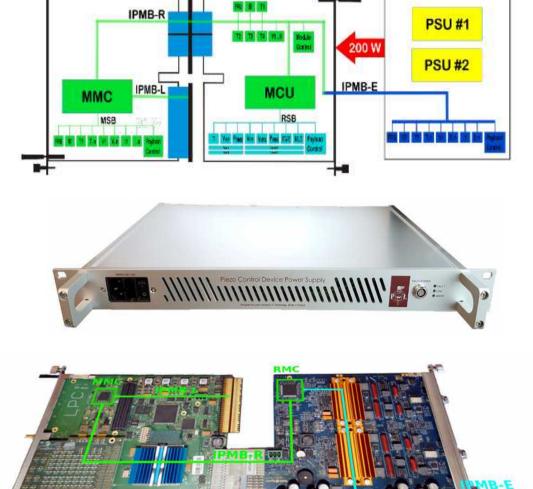
- Developing and testing new solutions
- Dynamic IPMI sensors for RTM
  - Available via IPMB-R
  - Requires RTM Management Controller
  - Implemented on Piezo Driver Module
- Management and control of External Piezo Power Supply
  - Diagnostics of external PPSM
    - Monitor temperatures
    - Monitor voltages
    - Monitor fans
  - Disable ±50 V voltage during hotplug:
    - AMC or RTM deactivated
    - AMC or RTM removed
    - Power supply cable removed
- FMC FRU support with unique ID





Dariusz Makowski on behalf of DMCS Team DESY, December 5, 2018



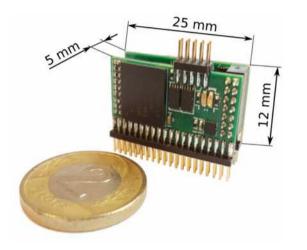


RTM

External PSM

#### **MMC Integrated Module – TUL-DMCS Solution**

- Easy solution for MTCA.4 beginners
- Ready to use module with universal and customisable firmware
- Available two versions:
  - Basic only AMC support
  - Advanced extended RTM manager with diagnostics
- Based on ARM microcontroller and real-time OS
- Programmable unit for more advanced customisation
- Under testing on HVC-50 AMC module





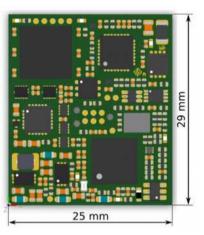


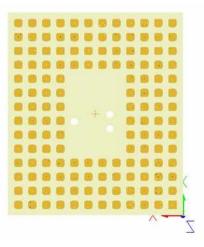




#### **MMC-Stamp Module – DESY Solution**

- Project developed by TUL-DMCS for DESY
  - See M. Fenner presentation: "DESY MMC System on a Module and its Applications" for more details
- Smart solution:
  - Module Management Controller dedicated for AMC modules
  - Extended solution supporting RTM
  - Atmel ARM microcontroller
  - Programmable FPGA logic
  - Available 4x I2C controllers
  - Small size











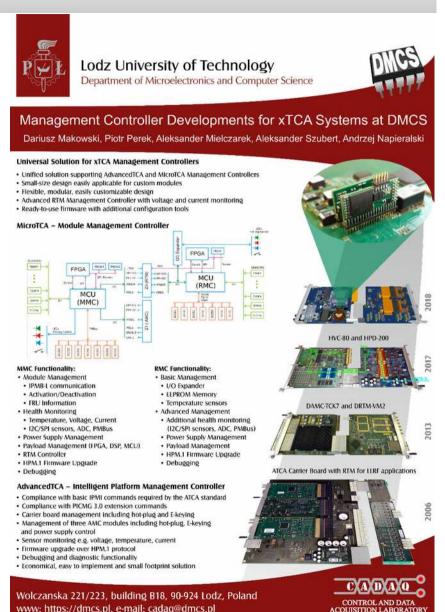
#### Interested – Visit our Poster

- We developed solutions for:
  - AdvancedTCA
  - MicroTCA

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- A few versions available
- Working on small-size but still powerful solution for xTCA applications



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DESY



## Image Acquisition and Processing System in MicroTCA.4



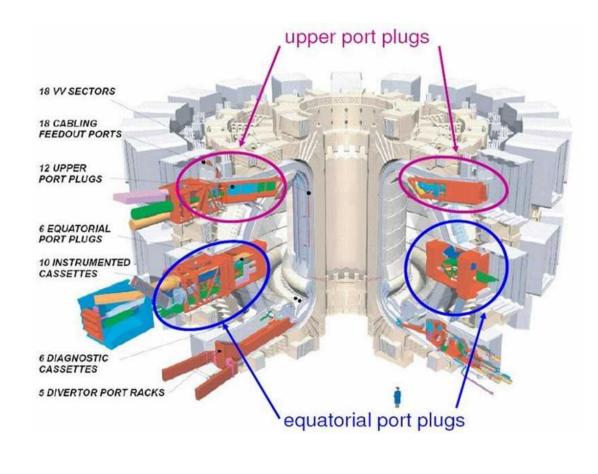




#### **ITER Project**

# Challenges in design of imaging systems for plasma diagnostics:

- Plasma diagnostics monitor plasma temperature, density, radiative properties, first-wall resilience
- 200 cameras:
  - 1-8 Mpx @ 50-50000 FPS
- Throughput can easily exceed 8 Gb/s per camera
- Scalability and high reliability
- 50 ns synchronization accuracy



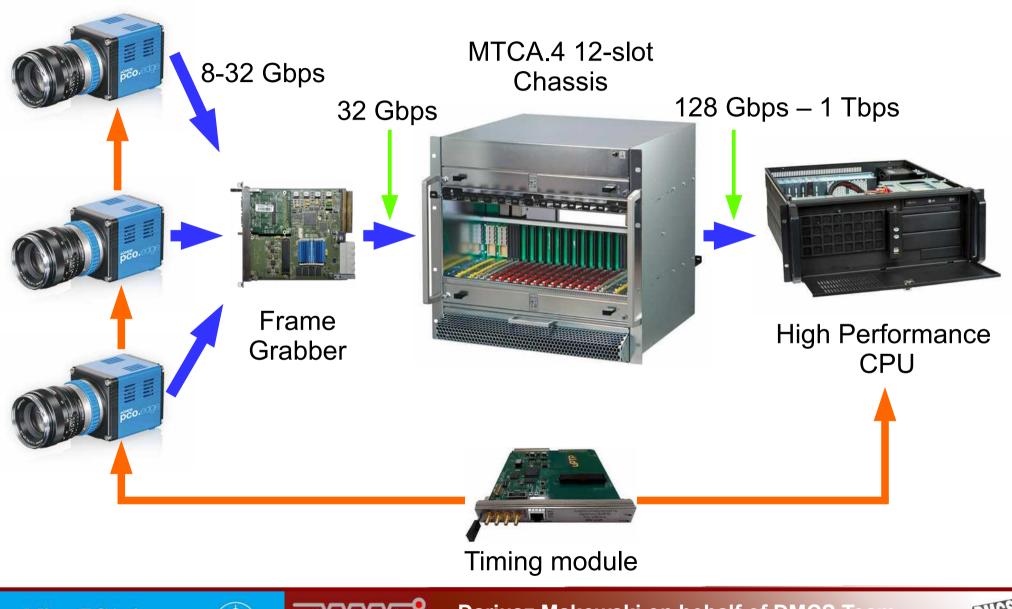
ITER Diagnostic Port Plugs







#### Image Acquisition and Processing with MTCA.4 – Our Solution



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#### Frame Grabber Card for MTCA.4

- Cost-effective solution for high-performance image acquisition systems
- Designed as FMC carrier module (HPC and LPC) with FMC extension modules:
  - Camera Link (Base, Full, Ext-Full)
  - Camera Link HS
  - CoaXPress
  - Universal IO module
  - Firmware support for selected protocols
- Provides all resources for data acquisition and control systems (FPGA processing power, SDRAM, clocks distribution, trigger and interlock signals)
- Based on Xilinx Artix 7 (XC7A200T) FPGA
- RTM Zone 3 connector (D1.2 Digital Class)

 Image Acquisition System with Full-Extended Camera Link



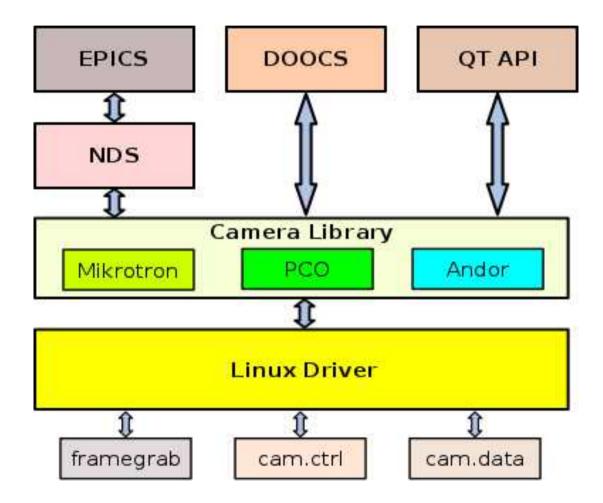




### Image Acquisition System – Software Framework

- API for EPICS, DOOCS and QT
- Library for 3 cameras:
  - Microtron
  - > PCO
  - > Andor
- Available nodes:
  - Frame Grabber
  - Camera control
  - Camera image
- Linux driver and NDS library

HMI panels







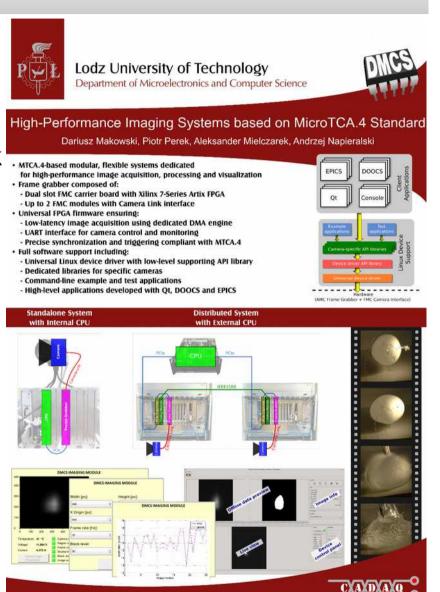


#### Interested – Visit our Poster

- Developed a complete Image Acquisition System for MicroTCA.4
- Various cameras supported
- Scalable and configurable software framework
- Support for new cameras could be easily added
- We are open for collaboration

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Dariusz Makowski on behalf of DMCS Team DESY, December 5, 2018



CONTROL AND DATA

#### Live Demo at TUL-DMCS Booth









## Thank you for your attention

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